

DEBBIE WASSERMAN SCHULTZ  
25<sup>TH</sup> DISTRICT, FLORIDA

CO-CHAIR,  
DEMOCRATIC STEERING & POLICY  
COMMITTEE

DEMOCRATIC DEAN & CO-CHAIR,  
FLORIDA DELEGATION



Congress of the United States  
House of Representatives

COMMITTEE ON APPROPRIATIONS

MILITARY CONSTRUCTION,  
VETERANS AFFAIRS, AND RELATED  
AGENCIES  
RANKING MEMBER

COMMITTEE ON THE JUDICIARY  
SELECT SUBCOMMITTEE ON THE  
WEAPONIZATION OF THE FEDERAL  
GOVERNMENT

March 31, 2023

The Honorable Kay Granger  
Chairwoman  
House Appropriations Committee  
U.S. House of Representatives  
Washington, DC 20515

The Honorable Rosa DeLauro  
Ranking Member  
House Appropriations Committee  
U.S. House of Representatives  
Washington, DC 20515

Dear Chairwoman Granger and Ranking Member DeLauro:

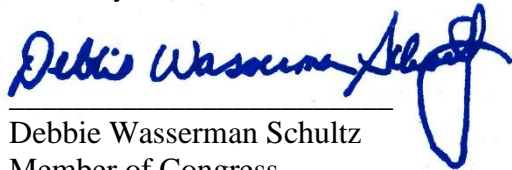
I am requesting funding for Advanced Materials Engineering Research Institute - Semiconductor Fabrication in fiscal year 2024. The entity to receive funding for this project is the Florida International University, located at 11200 SW 8 Street, Miami, FL 33199

The funding would be used to purchase state-of-the-art instrumentation, including Silicon Deep Reactive Ion Etching Systems, to enable the Advanced Materials Engineering Research Institute to create a test bed for semiconductor manufacturing and testing, fueling workforce development and engineering entrepreneurship. The Institute specializes in the realization of high-tech solutions to solve advanced technological problems for product development. This project would accelerate the development of technologies in high demand, such as semiconductors, while allowing students to build skills in support of their careers in the field of engineering.

The project has a Federal nexus because the funding provided is for purposes described in section 272 of title 15, United States Code.

I certify that I have no financial interest in this project, and neither does anyone in my immediate family.

Sincerely,

  
Debbie Wasserman Schultz  
Member of Congress